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CONFIRMATION NO. 5885

Bib Data Sheet

SERIAL NUMBER 10/054,373	FILING DATE 01/22/2002 RULE	CLASS 361	GROUP ART UNIT 2831	ATTORNEY DOCKET NO. AIBT 12K09
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** CONTINUING DATA ***** OK

** FOREIGN APPLICATIONS ***** OK

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** 02/19/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>[Signature]</u> Initials <u>ABT</u>	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
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TITLE

Semiconductor processing chamber substrate holder method and structure

FILING FEE RECEIVED 758	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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